

Supplementary Information

Machine-Learning Prediction of Metal Sulfide Photocatalysts for Sacrificial Hydrogen Evolution under Visible Light Irradiation

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Table S1 Conditions of convergence criteria for geometric optimization

Self-consistent field tolerance / eV atom ⁻¹	Energy tolerance / eV atom ⁻¹	Maximum force tolerance / eV Å ⁻¹	Displacement tolerance / Å	Max stress / GPa
1.0×10 ⁻⁶	1.0×10 ⁻⁵	0.03	1×10 ⁻³	0.1

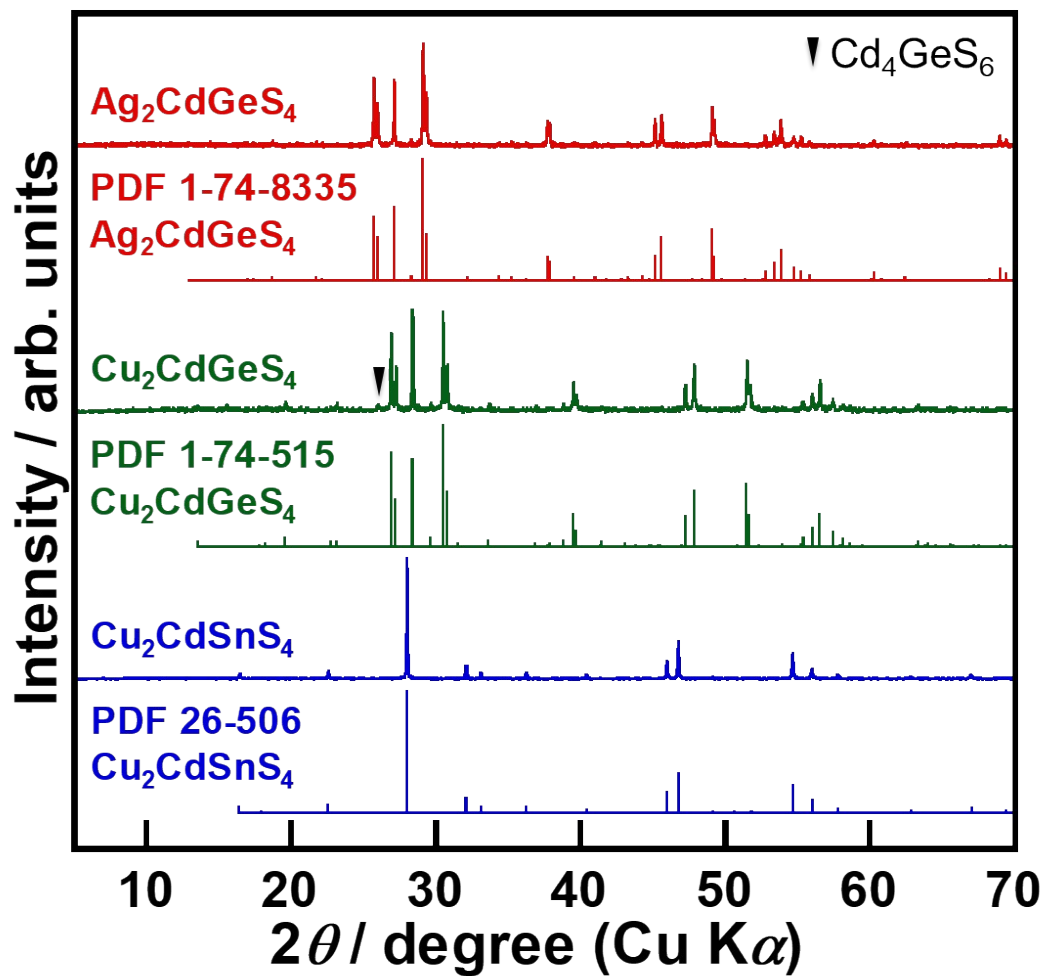


Figure S1 XRD patterns of $\text{Ag}_2\text{CdGeS}_4$ and Cu_2CdMS_4 (M=Ge and Sn) prepared by a solid-state reaction. Patterns due to $\text{K}\alpha_2$ were eliminated.

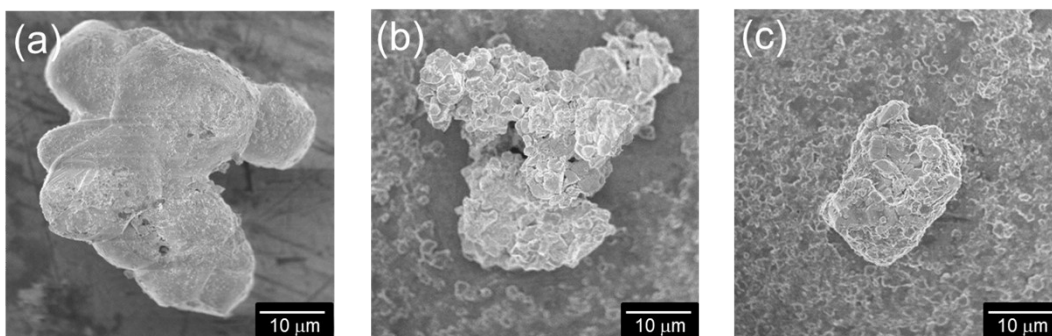


Figure S2 SEM images of (a) $\text{Ag}_2\text{CdGeS}_4$, (b) $\text{Cu}_2\text{CdGeS}_4$ and (c) $\text{Cu}_2\text{CdSnS}_4$ prepared by a solid-state reaction.

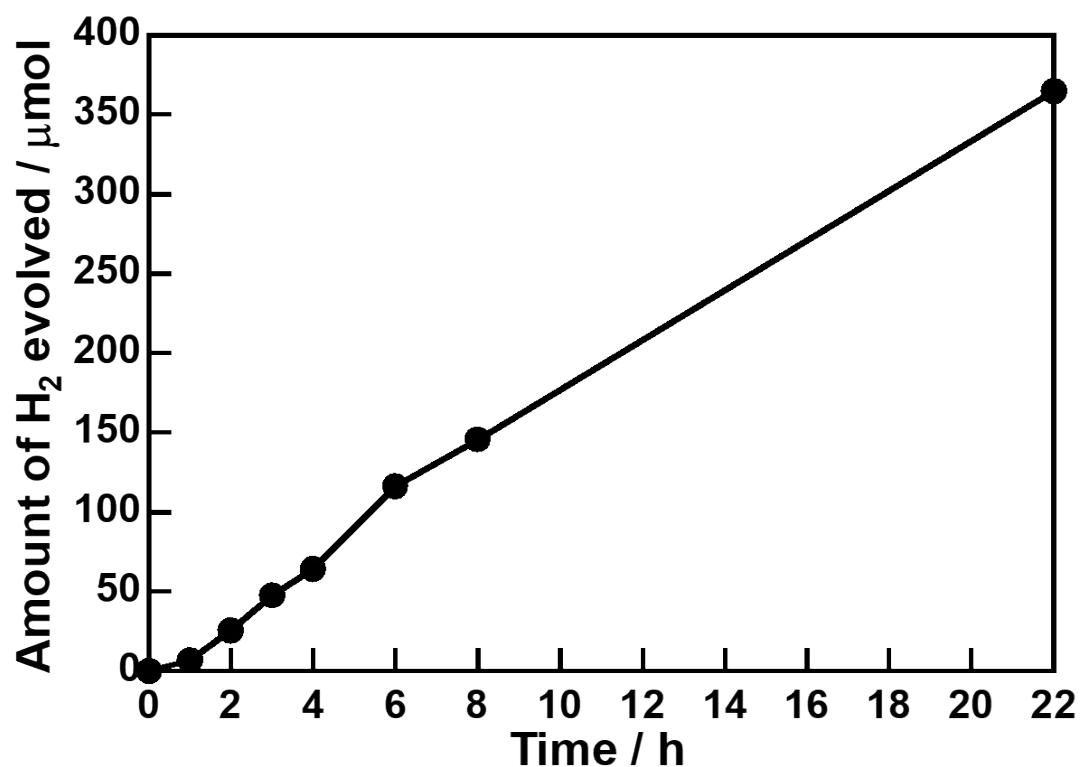


Figure S3 H₂ evolution over a Ru-loaded Cu₂CdSnS₄ photocatalyst prepared by a solid-state reaction from an aqueous solution containing sacrificial reagents under visible light irradiation. Photocatalyst: 0.3 g, cocatalyst: photodeposition in situ, reactant solution: 0.5 mol L⁻¹ K₂SO₃ and 0.1 mol L⁻¹ Na₂S aqueous solution (120 mL), cell: top-irradiation cell with a Pyrex window, light source: 300 W Xe lamp with a cut-off filter (HOYA: L42).